EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
		"5,967,795" 5,712,503; Ueno, et "al.", U.S. "Pat." "No." "5,789,311"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:41
L1	5506	filed near (shield plate relief)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:43
L2	10762	field near (shield plate relief)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:43
L3	73294	soi or silicon-on-insulator	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:43
L4	17576	bipolar same (pnp or npn)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:32
L5	1028	l3 and l4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:44
L6	72	l5 and (field near (plate or electrode or conductor))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:48
L7	813	l5 and gate	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:45

L8	8246	257/347,350,351,526,E27.112,E29.009,E29.01,E29.182,E29.184.ccls. 438/152,155.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:46
L9	22788584	@ad<"20020604" @rlad<"20020604"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:46
L10	57	l6 and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:46
L11	51	l5 and l2	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:48
L12	78	l11 andl9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:48
L13	38	l11 and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:00
L14	557	(field near plates) same (double multiple second two) and (bipolar bjt) and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:00
L15	603	(field near plates) same (double multiple second two) and (bipolar bjt pnp npn) and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:09

L16	113	(field near plates) same (double multiple second two) same (bipolar bjt pnp npn) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:09
L17	626	(field near plates metallization) same (double multiple second two) same (bipolar bjt pnp npn) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:09
L18	2	"5198379".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:11
L19	0	filed near plate and electrically near shield and (bjt bipolar near transistor) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:11
L20	0	filed near plates and electrically near shield and (bjt bipolar near transistor) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:11
L21	0	filed near plates same electrically near shield and (bjt bipolar near transistor) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:12
L22	0	field near plates same electrically near shield and (bjt bipolar near transistor) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:13
L23	16	electrically near shield and (bjt bipolar near transistor) and I9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:18

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L24	33732	pnp near transistor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:18
L25	1	pnp near transistor and filed near plates	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:19
L26	192	pnp near transistor and field near plates	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:19
L27	153	pnp near transistor and field near plates and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:30
L28	2	("6252248").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/09/21 13:32
L29	11531	(bipolar same (pnp or npn)) near transistor bjt	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:33
L30	11	(("6190948") or ("5420457") or ("5440161") or ("5731627") or ("5973341") or ("6118154")).PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/09/21 13:34
L31	6	(("6190948") or ("5420457") or ("5440161") or ("5731627") or ("5973341") or ("6118154")).PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	OFF	2006/09/21 13:36

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L32	1	filed near plate and bjt	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:36
L33	42	field near plate and bjt	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 13:41
S1	5479	filed near (shield plate relief)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/09/21 12:42
S2	10331	field near (shield plate relief)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 17:52
S3	67783	soi or (silicon near on near insulator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 17:52
S4	546	S2 and S3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 17:52
S5	362	S4 and @ad<"20020604"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 17:58
S6	304	S4 and metal$8 and (@ad<"20020604" or @rlad<"20020604")	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 18:02

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S7	298	S4 and metal$8 and (@ad<"20020604" or @rlad<"20020604") and between	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/04/25 18:02
S8	39	("4065781" | "4091527" | "4309715" | "4313809" | "4507846" | "4700454" | "4766482" | "4778775" | "4907053").PN. OR ("4996575").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 18:04
S9	48	("20010030722" | "20020080295" | "20020093019" | "20030038303" | "4609930" | "4748485" | "4977105" | "4984033" | "4996575" | "5034788" | "5103277" | "5124769" | "5140391" | "5185535" | "5198379" | "5233211" | "5246882" | "5273921" | "5275972" | "5281840" | "5294821" | "5315132" | "5327001" | "5359219" | "5371398" | "5420048" | "5463483" | "5470793" | "5475238" | "5485019" | "5506436" | "5521107" | "5532850" | "5580802" | "5604368" | "5621224" | "5646424" | "5702963" | "5807772" | "5818076" | "5917221" | "6054734" | "6225150" | "6252248" | "6323068" | "6330044" | "6479333" | "6603453").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 18:28
S10	14	(S9 S8 S7) and adhesive	US-PGPUB; USPAT; USOCR	OR	ON	2006/04/25 18:29
S11	2	("5198379").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/04/26 11:47